

Docket Number: 081468-0308582

Client Reference: P-1820.000-US



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

KLAUS SIMON

Group Art Unit: 1762

Application No.: 10/792,267

Examiner: Unassigned

Filed: March 4, 2004

Confirmation No.: 4229

For: PRINTING APPARATUS AND DEVICE MANUFACTURING METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Sir:

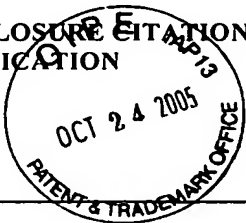
Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. The non-U.S. patent references and the article are attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom. Applicant respectfully requests the Examiner return an initialed copy of the enclosed Form PTO-1449 to Applicant with the next Office communication to indicate that the references have been considered, per MPEP § 609.

This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of the first Office Action on the merits in the present application. No certification or fee is required.

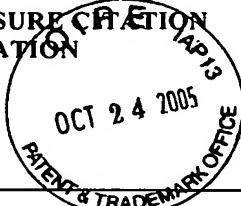
Respectfully Submitted,

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Registration Number 42663  
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Date: October 24, 2005  
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<b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b>  Form PTO-1449						Docket Number		Application Number	
				081468-0308582		10/792,267			
				Applicant(s)					
				Klaus SIMON					
				Filing Date		Group Art Unit			
				March 4, 2004		1762			
<b>U.S. PATENT DOCUMENTS</b>									
*EXAMINER INITIAL	REF	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE		
	A	6,921,615 B2	07/26/2005	Sreenivasan et al.	430	22			
	B	6,719,915 B2	04/13/2004	Willson et al.	216	44			
	C	6,696,220 B2	02/24/2004	Bailey et al.	430	272.1			
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	L	5,772,905	06/30/1998	Chou	216	44			
	M	5,512,131	04/30/1996	Kumar et al.	156	655.1			
	N	2005/0064054 A1	03/24/2005	Kasumi	425	112			
	O	2005/0039618 A1	02/24/2005	Heidari et al.	101	368			
	P	2004/0219461 A1	11/04/2004	Chung et al.	430	311			
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	T	2004/0192041 A1	09/30/2004	Jeong et al.	438	689			
	U	2004/0169003 A1	09/02/2004	Lee et al.	216	4			
	V	2004/0149367 A1	08/05/2004	Olsson et al.	156	64			
	W	2004/0124566 A1	07/01/2004	Sreenivasan et al.	264	494			
<b>FOREIGN PATENT DOCUMENTS</b>									
	REF	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translations		
							YES	NO	
	X	WO 01/79592 A1	10/25/2001	PCT					
	Y	WO 01/79591 A1	10/25/2001	PCT					
<b>OTHER DOCUMENTS</b> (Including Author, Title, Date, Pertinent Pages, Etc.)									
	X	Stephen Y. Chou, et al., "Nanoimprint Lithography", J. Vac. Sci. Technol. B 14(6), November/December 1996, pgs. 4129-4133.							
	Y								

EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.	

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*EXAMINER INITIAL	REF	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	A	2004/0081798 A1	04/29/2004	Lee et al.	428	141		
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	C	2004/0036201 A1	02/26/2004	Chou et al.	264	402		
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	Q	2003/0034329 A1	02/20/2003	Chou	216	44		
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	V	2002/0093122 A1	07/18/2002	Choi et al.	264	401		
	W							
<b>FOREIGN PATENT DOCUMENTS</b>								
	REF	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translations	
							YES	NO
	X							
	Y							
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>								
	X							
	Y							
	Z							
	AA							

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